

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
PATENT APPLICATION

In re Application of:

Tsung et al.

Docket: **TI-30243**

Serial No.: **09/921,324**

Art Unit: **2823**

Filed: **08/02/2001**

Examiner: **G. Fourson III**

For: **MASS PRODUCTION OF CROSS-SECTION TEM SAMPLES BY
FOCUSED ION BEAM DEPOSITION AND ANISOTROPIC ETCHING**

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 or is being facsimile transmitted on the date indicated below.

9-12-03

Jackie McBride
Jackie McBride

EXTENSION OF TIME

Sir:

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner for an extension of the shortened statutory period in the above-referenced application.

The fee for this extension is indicated below:

X One Month (\$110)

Please charge the fee to Deposit Account No. 20-0668. Any further necessary extension of time is hereby requested. Charge any additional fee or credit any overpayment to Deposit Account No. 20-0668.

Respectfully submitted,

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